

5

SPECIFICATION

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TITLE OF THE INVENTION
OPTICAL RECORDING MEDIUM,
METHOD FOR MANUFACTURING THE SAME AND
TARGET USED FOR SPUTTERING PROCESS

BACKGROUND OF THE INVENTION

The present invention relates to an optical recording medium, a method for manufacturing an optical recording medium and a target used for a sputtering process and, particularly, to an optical recording medium including a recording layer formed of materials that place minimal load on the global environment, a method for manufacturing such an optical recording medium, and a target used for a sputtering process that enables a recording layer of an optical recording medium to be formed of materials that place minimal load on the global environment.

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DESCRIPTION OF THE PRIOR ART

Optical recording media such as the CD, DVD and the like have been widely used as recording media for recording digital data. These optical recording media can be roughly classified into optical recording media such as the CD-ROM and the DVD-ROM that do not enable writing and rewriting of data (ROM type optical recording media), optical recording media such as the CD-R and DVD-R that enable writing but not rewriting of data (write-once type optical recording media), and optical recording media such as the CD-RW and DVD-RW that enable rewriting of data (data rewritable type optical recording media).

Data are generally recorded in a ROM type optical recording medium using prepits formed in a substrate in the manufacturing process thereof, while in a data rewritable type optical recording medium a phase change material is generally used as the material of the recording layer and data are recorded utilizing changes in an optical characteristic caused by phase change of the phase change material.

On the other hand, in a write-once type optical recording medium, an organic dye such as a cyanine dye, phthalocyanine dye or azo dye is

generally used as the material of the recording layer and data are recorded utilizing changes in an optical characteristic caused by chemical change of the organic dye, which change may be accompanied by physical deformation.

5 Unlike data recorded in a data rewritable type optical recording medium, data recorded in a write-once type optical recording medium cannot be erased and rewritten. This means that data recorded in a write-once type optical recording medium cannot be falsified, so that the write-once type optical recording medium is useful in the case where it is
10 necessary to prevent data recorded in an optical recording medium from being falsified.

However, since an organic dye is degraded when exposed to sunlight or the like, it is difficult to improve long-time storage reliability in the case where an organic dye is used as the material of the recording
15 layer. Therefore, it is desirable for improving long-time storage reliability of the write-once type optical recording medium to form the recording layer of a material other than an organic dye.

As disclosed in Japanese Patent Application Laid Open No. 62-204442, an optical recording medium including two recording layers
20 formed of inorganic materials is known as an example of an optical recording medium whose recording layer is formed of a material other than an organic dye.

However, the inorganic materials for forming recording layers of the optical recording medium disclosed in Japanese Patent Application
25 Laid Open No. 62-204442 include materials which place a heavy load on the environment so that the optical recording medium disclosed in Japanese Patent Application Laid Open No. 62-204442 does not satisfy the requirement for protecting global atmosphere.

SUMMARY OF THE INVENTION

It is therefore an object of the present invention to provide an optical recording medium including a recording layer formed of materials which place minimal load on the global environment.

It is another object of the present invention to provide a method for manufacturing an optical recording medium including a recording layer formed of materials which place minimal load on the global environment.

It is a further object of the present invention is to provide a target used for a sputtering process, which can form a recording layer of an optical recording medium of materials which place minimal load on the global environment.

The above and other objects of the present invention can be accomplished by an optical recording medium comprising at least one recording layer containing as a primary component an alloy containing at least two elements selected from the group consisting of Fe, Al and Si.

According to the present invention, since each of Fe, Al and Si is one of the most commonplace elements on earth and places only an extremely light load on the global environment, an optical recording medium including a recording layer containing as a primary component an alloy containing such elements can greatly lower the load placed on the global environment.

According to the present invention, when a laser beam is projected onto the recording layer of the optical recording medium, the alloy contained in the recording layer as a primary component is melted at a region of the recording layer irradiated with the laser beam and the phase of the alloy is changed when the melted alloy is solidified, thereby recording data in the recording layer.

The inventors did a study that will be explained with reference to the ternary composition diagram shown in Figure 1. In this ternary composition diagram, x_1 , y_1 and z_1 represent the atomic ratios (atomic %) of Fe, Al and Si in the composition of the alloy contained in the at least one recording layer of the optical recording medium as a primary component. The inventors discovered that when each of x_1 , y_1 and z_1 of the alloy composition $[x_1, y_1, z_1]$ in terms of the ternary composition diagram fell within the region of the pentagon defined by straight lines connecting a point A [57, 43, 0], a point B [0, 55, 45], a point C [15, 0, 85], a point D [89, 11, 0] and a point E [0, 16, 84] in the ternary composition diagram, it was possible to reproduce a signal having a high C/N ratio and low jitter, effectively suppress cross-talk of data and improve the recording sensitivity of the optical recording medium.

Therefore, in a preferred aspect of the present invention, the alloy contained in the at least one recording layer as a primary component has a composition $[x_1, y_1, z_1]$ in terms of the ternary composition diagram that falls within a region of a pentagon defined by straight lines connecting points [57, 43, 0], [0, 55, 45], [15, 0, 85], [89, 11, 0] and [0, 16, 84] in the ternary composition diagram.

In the present invention, the statement that the composition $[x_1, y_1, z_1]$ of the alloy in the ternary composition diagram falls within a region of a pentagon defined by straight lines connecting points [57, 43, 0], [0, 55, 45], [15, 0, 85], [89, 11, 0] and [0, 16, 84] in the ternary composition diagram includes a case where the composition $[x_1, y_1, z_1]$ of the alloy in the ternary composition diagram falls on any one of the sides of the pentagon.

In a further preferred aspect of the present invention, the optical recording medium further comprises a dielectric layer on at least one side

of the at least one recording layer.

According to this preferred aspect of the present invention, since the at least one recording layer is physically and chemically protected by the dielectric layer, degradation of recorded data can be effectively
5 prevented over a long period.

In a further preferred aspect of the present invention, the optical recording medium further comprises dielectric layers on opposite sides of the at least one recording layer.

The inventors of the present invention further vigorously pursued
10 a study for accomplishing the above and other objects and, as a result, made the following discovery regarding a recording layer of an optical recording medium formed by a sputtering process using a target containing as a primary component an alloy containing at least two elements selected from the group consisting of Fe, Al and Si. In the
15 ternary composition diagram shown in Figure 2, x_2 , y_2 and z_2 represent the atomic ratios (atomic %) of Fe, Al and Si of the alloy contained in the target as a primary component. The inventors discovered that when each of x_2 , y_2 and z_2 of the alloy composition $[x_2, y_2, z_2]$ in terms of the ternary composition diagram fell within the region of the pentagon defined by
20 straight lines connecting a point A' [55, 45, 0], a point B' [0, 50, 50], a point C' [9, 0, 91], a point D' [87, 13, 0] and a point E [0, 10, 90] in the ternary composition diagram, the result was that the alloy contained in the recording layer of the optical recording medium as a primary component came to have a composition $[x_1, y_1, z_1]$ in terms of the ternary
25 composition diagram that fell within a region of a pentagon defined by straight lines connecting a point A [57, 43, 0], a point B [0, 55, 45], a point C [15, 0, 85], a point D [89, 11, 0] and a point E [0, 16, 84] in the ternary composition diagram shown in Figure 1.

Therefore, the above and other objects of the present invention can be achieved by a target used for a sputtering process that contains as a primary component an alloy containing at least two elements selected from the group consisting of Fe, Al and Si, the alloy contained therein as a primary component having a composition $[x_2, y_2, z_2]$ in terms of a ternary composition diagram in which x_2 , y_2 and z_2 represent atomic ratios (atomic %) of Fe, Al and Si. and each of x_2 , y_2 and z_2 is defined to fall within a region of a pentagon defined by straight lines connecting a point A' [55, 45, 0], a point B' [0, 50, 50], a point C' [9, 0, 91], a point D' [87, 13, 0] and a point E [0, 10, 90] in the ternary composition diagram.

According to the present invention, it is possible to fabricate an optical recording medium which can reproduce a signal having a high C/N ratio and low jitter, can effectively suppress cross-talk of data and has an improved recording sensitivity.

In the present invention, the statement that a composition $[x_2, y_2, z_2]$ of the alloy contained in the target as a primary component falls within a region of a pentagon defined by straight lines connecting a point A' [55, 45, 0], a point B' [0, 50, 50], a point C' [9, 0, 91], a point D' [87, 13, 0] and a point E [0, 10, 90] in the ternary composition diagram includes a case where the composition $[x_2, y_2, z_2]$ of the alloy contained in the target as a primary component falls on any one of the sides of the pentagon.

The above and other objects of the present invention can be also accomplished by a method for manufacturing an optical recording medium comprising of a step of forming at least one recording layer of an optical recording medium by a sputtering process using a target that contains as a primary component an alloy containing at least two elements selected from the group consisting of Fe, Al and Si, the alloy contained therein as a primary component having a composition $[x_2, y_2, z_2]$

in terms of a ternary composition diagram in which x_2 , y_2 and z_2 represent atomic ratios (atomic %) of Fe, Al and Si. and each of x_2 , y_2 and z_2 is defined to fall within a region of a pentagon defined by straight lines connecting a point A' [55, 45, 0], a point B' [0, 50, 50], a point C' [9, 0, 91],
5 a point D' [87, 13, 0] and a point E [0, 10, 90] in the ternary composition diagram.

The above and other objects and features of the present invention will become apparent from the following description made with reference to the accompanying drawings.

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BRIEF DESCRIPTION OF THE DRAWINGS

Figure 1 is a ternary composition diagram of an alloy contained as a primary component in a recording layer of an optical recording medium.

Figure 2 is a ternary composition diagram of an alloy contained as
15 a primary component in a target used for a sputtering process.

Figure 3 is a schematic partially cutaway perspective view showing an optical recording medium that is a preferred embodiment of the present invention.

Figure 4 is an enlarged schematic cross-sectional view of the part
20 of the optical recording medium indicated by A in Figure 3.

Figure 5 is a schematic cross-sectional view showing a target used for a sputtering process.

Figure 6 is a diagram showing the waveform of a pulse train pattern for modulating the power of a laser beam in the case of recording
25 2T signals in a recording layer of an optical recording medium shown in Figures 3 and 4.

Figure 7 is a diagram showing the waveform of a pulse train pattern for modulating the power of a laser beam in the case of recording

3T signals in a recording layer of an optical recording medium shown in Figures 3 and 4.

Figure 8 is a diagram showing the waveform of a pulse train pattern for modulating the power of a laser beam in the case of recording 4T signals in a recording layer of an optical recording medium shown in Figures 3 and 4.

Figure 9 is a diagram showing the waveform of a pulse pattern for modulating the power of a laser beam in the case of recording one among a 5T signal to an 8T signal in a recording layer of an optical recording medium shown in Figures 3 and 4.

Figure 10 is a schematic cross-sectional view showing an optical recording medium which is another preferred embodiment of the present invention.

DESCRIPTION OF THE PREFERRED EMBODIMENTS

Figure 3 is a schematic partially cut perspective view showing an optical recording medium that is a preferred embodiment of the present invention and Figure 4 is a schematic enlarged cross-sectional view indicated by A in Figure 3.

As shown in Figure 3, an optical recording medium 10 according to this embodiment is formed disk-like and has an outer diameter of about 120 mm and a thickness of about 1.2 mm.

An optical recording medium 10 according to this embodiment is constituted as a write-once type optical recording medium and as shown in Figure 4, it includes a support substrate 11, a reflective layer 12 formed on the surface of the support substrate 11, a second dielectric layer 13 formed on the surface of the reflective layer 12, a recording layer 14 formed on the surface of the second dielectric layer 13, a first dielectric

layer 15 formed on the surface of the recording layer 14 and a light transmission layer 16 formed on the surface of the first dielectric layer 15.

In this embodiment, as shown in Figure 2, a laser beam L having a wavelength of 380 nm to 450 nm is projected onto a light incidence plane 16a constituted by one surface of the light transmission layer 16, thereby recording data in the optical recording medium 10 or reproducing data from the optical recording medium 10.

The support substrate 11 serves as a support for ensuring mechanical strength and a thickness of about 1.2 mm required for the optical recording medium 10.

The material used to form the support substrate 11 is not particularly limited insofar as the support substrate 11 can serve as the support of the optical recording medium 10. The support substrate 11 can be formed of glass, ceramic, resin or the like. Among these, resin is preferably used for forming the support substrate 11 since resin can be easily shaped. Illustrative examples of resins suitable for forming the support substrate 11 include polycarbonate resin, polyolefin resin, acrylic resin, epoxy resin, polystyrene resin, polyethylene resin, polypropylene resin, silicone resin, fluoropolymers, acrylonitrile butadiene styrene resin, urethane resin and the like. Among these, polycarbonate resin and polyolefin resin are most preferably used for forming the support substrate 11 from the viewpoint of easy processing, optical characteristics and the like and in this embodiment, the support substrate 11 is formed of polycarbonate resin. In this embodiment, since the laser beam L is projected via the light incident plane 16a located opposite to the support substrate 11, it is unnecessary for the support substrate 11 to have a light transmittance property.

As shown in Figure 4, grooves 11a and lands 11b are alternately

and spirally formed on the surface of the support substrate 11 so as to extend from a portion in the vicinity of the center of the support substrate 11 toward the outer circumference thereof or from the outer circumference of the support substrate 11 toward a portion in the vicinity of the center thereof. The grooves 11a and/or lands 11b serve as a guide track for the laser beam L.

The depth of the groove 11a is not particularly limited and is preferably set to 10 nm to 40 nm. The pitch of the grooves 11a is not particularly limited and is preferably set to 0.2 μm to 0.4 μm .

10 The reflective layer 12 serves to reflect the laser beam L entering through the light transmission layer 16 so as to emit it from the light transmission layer 16.

The material used to form the reflective layer 12 is not particularly limited insofar as it can reflect a laser beam L, and the reflective layer 12 can be formed of Mg, Al, Ti, Cr, Fe, Co, Ni, Cu, Zn, Ge, Ag, Pt, Au and the like. Among these materials, it is preferable to form the reflective layer 12 of a metal material having a high reflection characteristic, such as Al, Au, Ag, Cu or alloy containing at least one of these metals, such as alloy of Ag and Cu.

20 The reflective layer 12 also serves to increase the difference in reflection coefficient between a recorded region and an unrecorded region by a multiple interference effect, thereby obtaining a higher reproduced signal (C/N ratio).

The thickness of the reflective layer 12 is not particularly limited but is preferably from 5 nm to 300 nm, more preferably from 20 nm to 200 nm.

In the case where the thickness of the reflective layer 12 is thinner than 5 nm, it is difficult to reflect a laser beam L in a desired manner. On

the other hand, in the case where the thickness of the reflective layer 12 exceeds 300 nm, the surface smoothness of the reflective layer 12 becomes worse and it takes a longer time for forming the reflective layer 12, thereby lowering the productivity of the optical recording medium 10.

5 The first dielectric layer 15 and the second dielectric layer 13 serve to protect the recording layer 14. Degradation of recorded data can be prevented over a long period by the first dielectric layer 15 and the second dielectric layer 13.

10 The material for forming the first dielectric layer 15 and the second dielectric layer 13 is not particularly limited insofar as it is transparent in the wavelength range of the laser beam L and the first dielectric layer 15 and the second dielectric layer 13 can be formed of a dielectric material containing oxide, sulfide, nitride, carbide or a combination thereof, for example, as a primary component. In order to
15 prevent the support substrate 11 from being deformed by heat and improve the characteristics of the first dielectric layer 15 and the second dielectric layer 13 for protecting the recording layer 14, it is preferable to form the first dielectric layer 15 and the second dielectric layer 13 of an oxide, sulfide, nitride or carbide of Al, Si, Ce, Ti, Zn, Ta or the like, such as
20 Al₂O₃, AlN, ZnO, ZnS, GeN, GeCrN, CeO, CeO₂, SiO, SiO₂, Si₃N₄, SiC, La₂O₃, TaO, TiO₂, SiAlON (mixture of SiO₂, Al₂O₃, Si₃N₄ and AlN), LaSiON (mixture of La₂O₃, SiO₂ and Si₃N₄) or the like, or the mixture thereof.

25 The first dielectric layer 15 and the second dielectric layer 13 may be formed of the same dielectric material or of different dielectric materials. Moreover, at least one of the first dielectric layer 15 and the second dielectric layer 13 may have a multi-layered structure including a plurality of dielectric films.

The first dielectric layer 15 and the second dielectric layer 13 also serve to increase the difference in optical properties of the optical recording medium 10 between before and after data recording and it is therefore preferable to form the first dielectric layer 15 and the second dielectric layer 13 of a material having a high refractive index n in the wavelength range of the laser beam L. Further, since the recording sensitivity becomes low as the energy absorbed in the first dielectric layer 15 and the second dielectric layer 13 becomes large when the laser beam L is projected onto the optical recording medium 10 and data are to be recorded therein, it is preferable to form the first dielectric layer 15 and the second dielectric layer 13 of a material having a low extinction coefficient k in the wavelength range of the laser beam L.

In view of the above, it is particularly preferable to form the first dielectric layer 15 and the second dielectric layer 13 of a mixture of ZnS and SiO₂ whose mole ratio is 80:20.

The thickness of the first dielectric layer 15 and the second dielectric layer 13 is not particularly limited but is preferably from 3 nm to 200 nm. If the first dielectric layer 15 or the second dielectric layer 13 is thinner than 3 nm, it is difficult to obtain the above-described advantages. On the other hand, if the first dielectric layer 15 or the second dielectric layer 13 is thicker than 200 nm, it takes a long time to form the first dielectric layers 15 and the second dielectric layers 13, thereby lowering the productivity of the optical recording medium 10, and cracks may be generated in the first dielectric layers 15 and/or the second dielectric layers 13 owing to stress present in the first dielectric layers 15 and/or the second dielectric layer 13.

The recording layer 14 is adapted for forming a record mark and recording data therein.

In this embodiment, the recording layer 14 contain as a primary component an alloy containing at least two elements selected from the group consisting of Fe, Al and Si.

Since each of Fe, Al and Si is one of the most commonplace
5 elements on earth and puts only an extremely light load on the global environment, an optical recording medium 10 including a recording layer 14 containing as a primary component an alloy containing such elements can greatly lower the load placed the global environment.

More specifically, the alloy contained in the recording layer 14 of
10 the optical recording medium 10 as a primary component has a composition $[x_1, y_1, z_1]$ in the ternary composition diagram shown in Figure 1, in which x_1 , y_1 and z_1 represent atomic ratios (atomic %) of Fe, Al and Si contained in the alloy, such that each of x_1 , y_1 and z_1 falls within a region 100 of a pentagon defined by straight lines connecting a point A [57,
15 43, 0], a point B [0, 55, 45], a point C [15, 0, 85], a point D [89, 11, 0] and a point E [0, 16, 84] in the ternary composition diagram.

In a study done by the inventors of the present invention, it was found that in the case where the alloy contained in the recording layer 14 of the optical recording medium 10 as a primary component had a
20 composition $[x_1, y_1, z_1]$ in the ternary composition diagram shown in Figure 1 that fell within a region of a pentagon defined by straight lines connecting a point A [57, 43, 0], a point B [0, 55, 45], a point C [15, 0, 85], a point D [89, 11, 0] and a point E [0, 16, 84] in the ternary composition diagram, it was possible to reproduce a signal having a high C/N ratio and
25 low jitter, effectively suppress cross-talk of data and improve the recording sensitivity of the optical recording medium 10.

In the case where the alloy contained in the recording layer 14 of the optical recording medium 10 as a primary component had a

composition $[x_1, y_1, z_1]$ in the ternary composition diagram shown in Figure 1 that fell within the region of the triangle defined by straight lines connecting the point A, the point B and a point where the content of Al was equal to 100 atomic %, large crystals of Al were apt to be generated
5 when the recording layer 14 was irradiated with a laser beam L,. As a result, the record marks became large and data cross-talk increased. Further, even if data were recorded in the recording layer 14 using a laser beam L having a low power in order to prevent generation of large crystals of Al, data still could not be recorded in the recording layer 14 in
10 a desired manner because heat easily transmitted in the recording layer 14,.

On the other hand, in the case where the alloy contained in the recording layer 14 of the optical recording medium 10 as a primary component had a composition $[x_1, y_1, z_1]$ in the ternary composition
15 diagram shown in Figure 1 that fell within the region of the triangle defined by straight lines connecting the point C, the point D and a point where the content of Fe was equal to 100 atomic % or fell within the region of the triangle defined by straight lines connecting the point C, the point E and a point where the content of Si was equal to 100 atomic %, the
20 phase of the alloy did not change unless the recording layer 14 was heated to a high temperature and, therefore, the recording sensitivity of the optical recording medium 10 was low.

As the thickness of the recording layer 14 increases, the recording sensitivity becomes worse and since the amount of a laser beam L
25 absorbed in the recording layer 14 increases, the reflective coefficient is lowered. Therefore, it is preferable make the recording layer thinner in order to prevent the recording sensitivity from becoming worse and the reflective coefficient from being lowered, but in the case where the

thickness of the recording layer 14 is too small, the change in reflection coefficient between before and after irradiation with the laser beam L is small, so that a reproduced signal having high strength (C/N ratio) cannot be obtained. Moreover, it becomes difficult to control the thickness of the
5 recording layer 14.

Therefore, it is preferable to form the recording layer 14 to have a thickness of 3 nm to 40 nm and more preferable to form it to have a thickness of 5 nm to 30 nm.

The light transmission layer 16 serves to transmit a laser beam L
10 and preferably has a thickness of 10 μm to 300 μm . More preferably, the light transmission layer 16 has a thickness of 50 μm to 150 μm .

The material used to form the light transmission layer 16 is not particularly limited but in the case where the light transmission layer 16 is to be formed by the spin coating process or the like, ultraviolet ray curable resin, electron beam curable resin or the like is preferably used.
15 More preferably, the light transmission layer 16 is formed of acrylic ultraviolet ray curable resin or epoxy ultraviolet ray curable resin.

The light transmission layer 16 may be formed by adhering a sheet made of light transmittable resin to the surface of the first dielectric layer
20 15 using an adhesive agent.

The optical recording medium 10 having the above-described configuration can, for example, be fabricated in the following manner.

The support substrate 11 having grooves 11a and lands 11b on the surface thereof is first fabricated by an injection molding process using a
25 stamper.

The reflective layer 12 is then formed on the surface of the substrate 11 formed with the grooves 11a and lands 11b.

The reflective layer 12 can be formed by a vapor growth process

using chemical species containing elements for forming the reflective layer 12. Illustrative examples of the vapor growth processes include vacuum deposition process, sputtering process and the like but it is preferable to form the reflective layer 12 using the sputtering process.

5 The second dielectric layer 13 is then formed on surface of the reflective layer 12.

 The second dielectric layer 13 can be also formed by a vapor growth process using chemical species containing elements for forming the second dielectric layer 13. Illustrative examples of the vapor growth
10 processes include vacuum deposition process, sputtering process and the like but it is preferable to form the second dielectric layer 13 using the sputtering process.

 The recording layer 14 is then formed on the second dielectric layer 13.

15 The recording layer 14 can be formed by a vapor growth process using an alloy containing at least two elements selected from the group consisting of Fe, Al and Si. Illustrative examples of the vapor growth processes include vacuum deposition process, sputtering process and the like but it is preferable to form the second dielectric layer 13 using the
20 sputtering process.

 The inventors of the present invention conducted a study that led to the following discovery regarding a recording layer 14 of an optical recording medium 10 formed by a sputtering process using a target containing as a primary component an alloy containing at least two
25 elements selected from the group consisting of Fe, Al and Si. In the ternary composition diagram shown in Figure 2, x_2 , y_2 and z_2 represent the atomic ratios (atomic %) of Fe, Al and Si of the alloy contained in the target as a primary component. The inventors discovered that when each

of x_2 , y_2 and z_2 of the alloy composition $[x_2, y_2, z_2]$ in terms of the ternary composition diagram fell within the region of the pentagon defined by straight lines connecting a point A' [55, 45, 0], a point B' [0, 50, 50], a point C' [9, 0, 91], a point D' [87, 13, 0] and a point E [0, 10, 90] in the
5 ternary composition diagram, the result was that the alloy contained in the recording layer of the optical recording medium as a primary component came to have a composition $[x_1, y_1, z_1]$ in terms of the ternary composition diagram that fell within the region of the pentagon defined by straight lines connecting a point A [57, 43, 0], a point B [0, 55, 45], a
10 point C [15, 0, 85], a point D [89, 11, 0] and a point E [0, 16, 84] in the ternary composition diagram shown in Figure 1.

The target used for the sputtering process can be fabricated by mixing powder containing as a primary component an alloy containing at least two elements selected from the group consisting of Fe, Al and Si,
15 baking the mixed powder, cutting the baked product so as to have a predetermined shape and size and soldering it onto a backing plate made of a copper alloy, stainless steel, a titanium alloy, a molybdenum alloy or the like.

Figure 5 is a schematic cross-sectional view showing the thus
20 fabricated target.

As shown in Figure 5, the thus fabricated target 21 is formed on the backing plate 22.

The shape and size of the target can be selected in accordance with the sputtering apparatus and the target may have a circular cross-section
25 of about 200 mm diameter or be a rectangular parallelepiped having a major surface of about 200 mm x about 100 mm.

The first dielectric layer 15 is then formed on the recording layer 14. The first dielectric layer 15 can be also formed by a gas phase growth

process using chemical species containing elements for forming the first dielectric layer 15.

Finally, the light transmission layer 16 is formed on the first dielectric layer 15. The light transmission layer 16 can be formed, for example, by applying an acrylic ultraviolet ray curable resin or epoxy ultraviolet ray curable resin adjusted to an appropriate viscosity onto the surface of the second dielectric layer 15 by spin coating to form a coating layer and irradiating the coating layer with ultraviolet rays to cure the coating layer.

Thus, the optical recording medium 10 was fabricated.

In the case where data are to be recording in the optical recording medium 10 of the above-described configuration, a laser beam L whose power is modulated is projected onto the recording layer 14 via the light transmission layer 16, while the optical recording medium 10 is being rotated.

In order to record data with high recording density, it is preferable to project a laser beam L having a wavelength λ of 450 nm or shorter onto the optical recording medium 10 via an objective lens (not shown) having a numerical aperture NA of 0.7 or more and it is more preferable that λ/NA be equal to or smaller than 640 nm.

In this embodiment, a laser beam L having a wavelength λ of 405 nm is projected onto the optical recording medium 10 via an objective lens having a numerical aperture NA of 0.85.

As a result, an alloy contained in the recording layer as a primary component is melted at the region of the recording layer 14 irradiated with the laser beam L and the phase thereof is changed when the melted alloy is solidified, whereby a record mark is formed and data are recorded in the recording layer 14 of the optical recording medium 10.

On the other hand, in the case where data recorded in the recording layer 14 of the optical recording medium 10 are to be reproduced, a laser beam L having a predetermined power is projected onto the recording layer 14 via the light transmission layer 16, while the optical recording medium 10 is being rotated, and the amount of the laser beam L reflected by the recording layer 14 is detected, whereby data recorded in the recording layer 14 of the optical recording medium 10 are reproduced.

Each of Figures 6 to 9 is a diagram showing the waveform of a pulse pattern for modulating the power of the laser beam L in the case of recording data in the recording layer 14 of the optical recording medium 10, where Figure 6 shows a pulse pattern used in the case of recording 2T signals, Figure 7 shows a pulse pattern used in the case of recording 3T signals, Figure 8 shows a pulse pattern used in the case of recording 4T signals and Figure 9 shows random signals used in the case of recording one among a 5T signal to an 8T signal.

As shown in Figures 7 to 10, the power of the laser beam L is modulated between two levels, a recording power P_w and a bottom power P_b where $P_w > P_b$.

The recording power P_w is set to a high level capable of melting and changing the phase of an alloy contained in the recording layer 14 of the optical recording medium 10 when the laser beam L set to the recording power P_w is projected onto the recording layer 14. On the other hand, the bottom power P_b is set to an extremely low level at which a region of the recording layer 14 heated by irradiation with the laser beam L set to the recording power P_w can be cooled during irradiation with the laser beam L set to the bottom power P_b .

As shown in Figure 6, in the case of recording a 2T signal in the

recording layer 14 of the optical recording medium 10, the power of the laser beam L is modulated to be increased from the bottom power Pb to the recording power Pw at a time $t11$ and decreased from the recording power Pw to the bottom power Pb at a time $t12$ after passage of a
5 predetermined time period t_{top} .

Therefore, in the case of recording a 2T signal in the L0 information recording layer 20 or the L1 information recording layer 30 of the optical recording medium 10, the number of a pulse having a level equal to the recording power Pw is set to be 1.

10 On the other hand, as shown in Figure 7, in the case of recording a 3T signal in the recording layer 14 of the optical recording medium 10, the power of the laser beam L is modulated so that it is increased from the bottom power Pb to the recording power Pw at a time $t21$, decreased from the recording power Pw to the bottom power Pb at a time $t22$ after
15 passage of a predetermined time period t_{top} , increased from the bottom power Pb to the recording power Pw at a time $t23$ after passage of a predetermined time period t_{off} and decreased from the recording power Pw to the bottom power Pb at a time $t24$ after passage of a predetermined time period t_{lp} .

20 Therefore, in the case of recording a 3T signal in the recording layer 14 of the optical recording medium 10, the number of pulses each having a level equal to the recording power Pw is set to be 2.

Further, as shown in Figure 8, in the case of recording a 4T signal in the recording layer 14 of the optical recording medium 10, the power of
25 the laser beam L is modulated so that it is increased from the bottom power Pb to the recording power Pw at a time $t31$, decreased from the recording power Pw to the bottom power Pb at a time $t32$ after passage of a predetermined time period t_{top} , increased from the bottom power Pb to

the recording power P_w at a time t_{33} after passage of a predetermined time period t_{off} decreased from the recording power P_w to the bottom power P_b at a time t_{34} after passage of a predetermined time period t_{mp} increased from the bottom power P_b to the recording power P_w at a time t_{35} after passage of a predetermined time period t_{off} and decreased from the recording power P_w to the bottom power P_b at a time t_{36} after passage of a predetermined time period t_{lp} .

Therefore, in the case of recording a 4T signal in the recording layer 14 of the optical recording medium 10, the number of pulses each having a level equal to the recording power P_w is set to be 3.

Moreover, as shown in Figure 9, in the case of recording one among a 5T signal to an 8T signal in the recording layer 14 of the optical recording medium 10, the power of the laser beam L is modulated so that it is increased from the bottom power P_b to the recording power P_w at a time t_{41} , held at the recording power P_w during the time period t_{top} , the time periods t_{mp} and the time period t_{lp} , held at the bottom power P_b during the time periods t_{off} and decreased from the recording power P_w to the bottom power P_b at a time t_{48} .

Therefore, in the case of recording one among a 5T signal to a 8T signal in the recording layer 14 of the optical recording medium 10, the number of pulses each having a level equal to the recording power P_w is set to be 4 to 7.

When the recording layer 14 is irradiated with the laser beam L set to the recording power P_w , an alloy contained in the recording layer 14 as a primary component is melted at a region of the recording layer 14 irradiated with the laser beam L, and when it is irradiated with the laser beam L set to the bottom power P_b , the melted alloy is solidified and the phase of the alloy is changed, whereby a record mark is formed and data

are recorded in the recording layer 14.

Since the reflective coefficient with respect to a laser beam L of a region of the recording layer 14 where the record mark is formed in this manner and that of a region where no record mark is formed, namely, a blank region, are greatly different, data recorded in the recording layer 14 can be reproduced utilizing the difference in the reflection coefficients between the region of the recording layer 14 where the record mark is formed and the blank region.

The length of the record mark and the length of the blank region between the record mark and the neighboring record mark constitute data recorded in the recording layer 14. The record mark and the blank region are formed so as to have a length equal to an integral multiple of T, where T is a length corresponding to one cycle of a reference clock. In the case where 1,7 RLL modulation code is employed, record marks and blank regions having a length of 2T to 8T are formed.

According to this embodiment, since the recording layer 14 of the optical recording medium 10 contains as a primary component an alloy containing at least two elements selected from Fe, Al and Si and each of Fe, Al and Si is one of the most commonplace elements on earth and applies extremely light load to the global environment, an optical recording medium 10 including the recording layer 14 containing as a primary component an alloy containing such elements can lower the load placed on the global environment.

Further, according to this embodiment, the alloy contained in the recording layer 14 of the optical recording medium 10 as a primary component has a composition $[x_1, y_1, z_1]$ in the ternary composition diagram shown in Figure 1, in which x_1 , y_1 and z_1 represent atomic ratios (atomic %) of Fe, Al and Si contained in the alloy, such that each of x_1 , y_1

and z_1 falls within a region 100 of a pentagon defined by straight lines connecting a point A [57, 43, 0], a point B [0, 55, 45], a point C [15, 0, 85], a point D [89, 11, 0] and a point E [0, 16, 84] in the ternary composition diagram, it is possible to reproduce a signal having a high C/N ratio and low jitter, effectively suppress cross-talk of data and improve the recording sensitivity of the optical recording medium 10.

Figure 10 is a schematic cross-sectional view showing an optical recording medium which is another preferred embodiment of the present invention.

As shown in Figure 10, the optical recording medium 30 according to this embodiment includes a support substrate 31, a transparent intermediate layer 32, a light transmission layer (protective layer) 33, an L0 information recording layer 40 formed between the support substrate 31 and the transparent intermediate layer 32, and an L1 information recording layer 50 formed between the transparent layer 32 and the light transmission layer 33.

The L0 information recording layer 40 and the L1 information recording layer 50 are information recording layers in which data are recorded, i.e., the optical recording medium 30 according to this embodiment includes two information recording layers.

The L0 information recording layer 40 constitutes an information recording layer far from a light incident plane 33a and is constituted by laminating a reflective layer 41, a fourth dielectric layer 42, an L0 recording layer 43 and a third dielectric layer 44 from the side of the support substrate 31.

On the other hand, the L1 information recording layer 50 constitutes an information recording layer close to the light incident plane 33a and is constituted by laminating a reflective layer 51, a second

dielectric layer 52, an L1 recording layer 53 and a first dielectric layer 54 from the side of the support substrate 31.

The support substrate 31 serves as a support for ensuring the mechanical strength and thickness of about 1.2 mm required by the optical recording medium 30 and is formed in the same way as the support substrate 11 of the optical recording medium 10 shown in Figures 3 and 4.

As shown in Figure 10, grooves 31a and lands 31b are alternately and spirally formed on the surface of the support substrate 31 so as to have a depth and a pitch similar to those of the optical recording medium 10 shown in Figures 3 and 4. The grooves 31a and/or lands 31b serve as a guide track for the laser beam L when data are to be recorded in the L0 information recording layer 40 or when data are to be reproduced from the L0 information recording layer 40.

The transparent intermediate layer 32 serves to space the L0 information recording layer 40 and the L1 information recording layer 50 apart by a physically and optically sufficient distance.

As shown in Figure 10, grooves 32a and lands 32b are alternately formed on the surface of the transparent intermediate layer 32. The grooves 32a and/or lands 32b formed on the surface of the transparent intermediate layer 32 serve as a guide track for the laser beam L when data are to be recorded in the L1 layer 50 or when data are to be reproduced from the L1 layer 50.

The depth of the groove 32a and the pitch of the grooves 32a can be set to be substantially the same as those of the grooves 31a formed on the surface of the support substrate 31.

It is preferable to form the transparent intermediate layer 32 so as to have a thickness of 5 μm to 50 μm and it is more preferable to form it so

as to have a thickness of 10 μm to 40 μm .

The material for forming the transparent intermediate layer 32 is not particularly limited and an ultraviolet ray curable acrylic resin is preferably used for forming the transparent intermediate layer 32.

5 It is necessary for the transparent intermediate layer 32 to have sufficiently high light transmittance since the laser beam L passes through the transparent intermediate layer 32 when data are to be recorded in the L0 information recording layer 40 and data recorded in the L0 information recording layer 40 are to be reproduced.

10 The transparent intermediate layer 32 is preferably formed by a 2P process using a stamper but the transparent intermediate layer 32 may be formed by other processes.

 The light transmission layer 33 serves to transmit the laser beam L and the light incident plane 33a is constituted by one of the surfaces
15 thereof.

 The light transmission layer 33 is formed in the same way as the light transmission layer 16 of the optical recording medium 10 shown in Figures 3 and 4.

 The L0 recording layer 43 included in the L0 information recording
20 layer 40 contains as a primary component an alloy containing at least two elements selected from the group consisting of Fe, Al and Si.

 The alloy contained in the L0 recording layer 43 included in the L0 information recording layer 40 of the optical recording medium 30 as a primary component has a composition $[x_1, y_1, z_1]$ in the ternary
25 composition diagram shown in Figure 1, in which x_1 , y_1 and z_1 represent atomic ratios (atomic %) of Fe, Al and Si contained in the alloy, such that each of x_1 , y_1 and z_1 falls within a region of a pentagon defined by straight lines connecting a point A [57, 43, 0], a point B [0, 55, 45], a point C [15, 0,

85], a point D [89, 11, 0] and a point E [0, 16, 84] in the ternary composition diagram.

Similarly, the L1 recording layer 53 included in the L1 information recording layer 50 contains as a primary component an alloy containing
5 at least two elements selected from the group consisting of Fe, Al and Si.

The alloy contained in the L1 recording layer 53 included in the L1 information recording layer 50 of the optical recording medium 30 as a primary component has a composition $[x_1, y_1, z_1]$ in the ternary composition diagram shown in Figure 1, in which x_1 , y_1 and z_1 represent
10 atomic ratios (atomic %) of Fe, Al and Si contained in the alloy, such that each of x_1 , y_1 and z_1 falls within a region of a pentagon defined by straight lines connecting a point A [57, 43, 0], a point B [0, 55, 45], a point C [15, 0, 85], a point D [89, 11, 0] and a point E [0, 16, 84] in the ternary composition diagram.

15 Each of the reflective layer 41 included in the L0 information recording layer 40 and the reflective layer 51 included in the L1 information recording layer 50 is formed in the same way as the reflective layer 12 of the optical recording medium 10 shown in Figures 3 and 4.

Each of the fourth dielectric layer 42 and the third dielectric layer
20 44 included in the L0 information recording layer 40 and the second dielectric layer 52 and the first dielectric layer 54 included in the L1 information recording layer 50 is formed in the same way as the first dielectric layer 15 or the second dielectric layer 13 of the optical recording medium 10 shown in Figures 3 and 4.

25 Each of the reflective layer 41, the fourth dielectric layer 42, the L0 recording layer 43 and the third dielectric layer 44 included in the L0 information recording layer 40, and the reflective layer 51, the second dielectric layer 52, the L1 recording layer 53 and the first dielectric layer

54 included in the L1 information recording layer 50 can be formed by a vapor growth process using chemical species containing elements for forming it. Illustrative examples of the vapor growth processes include a sputtering process, vacuum deposition process and the like and the sputtering process is preferably used for forming them.

When data are to be recorded in the L0 recording layer 43 included in the L0 information recording layer 40 of the optical recording medium 30, a laser beam L set to the recording power P_w is focused onto the L0 recording layer 43 via the light transmission layer 33. As a result, an alloy contained in the L0 recording layer 43 as a primary component is melted at the region of the L0 recording layer 43 irradiated with the laser beam L and when the laser beam L is set to the bottom power P_b , the melted alloy is solidified and the phase of the alloy is changed, whereby a record mark is formed and data are recorded in the L0 recording layer 43.

On the other hand, when data are to be recorded in the L1 recording layer 53 included in the L1 information recording layer 50 of the optical recording medium 30, a laser beam L set to the recording power P_w is focused onto the L1 recording layer 53 via the light transmission layer 33. As a result, an alloy contained in the L1 recording layer 53 as a primary component is melted at the region of the L1 recording layer 53 irradiated with the laser beam L and when the laser beam L is set to the bottom power P_b , the melted alloy is solidified and the phase of the alloy is changed, whereby a record mark is formed and data are recorded in the L1 recording layer 53.

When data recorded in the L0 recording layer 43 included in the L0 information recording layer 40 of the optical recording medium 30 are to be reproduced, a laser beam L set to a reproducing power is focused onto the L0 recording layer 43 via the light transmission layer 33 and the

amount of the laser beam L reflected by the L0 recording layer 43 is detected.

On the other hand, when data recorded in the L1 recording layer 53 included in the L1 information recording layer 50 of the optical recording medium 30 are to be reproduced, a laser beam L set to be a reproducing power is focused onto the L1 recording layer 53 via the light transmission layer 33 and the amount of the laser beam L reflected by the L1 recording layer 53 is detected.

According to this embodiment, since each of the L0 recording layer 43 and the L1 recording layer 53 contains as a primary component an alloy containing at least two elements selected from Fe, Al and Si and each of Fe, Al and Si is one of the most commonplace elements on earth and places only extremely light load on the global environment, an optical recording medium 30 including the L0 recording layer 43 and the L1 recording layer 53 each containing as a primary component an alloy containing such elements can lower the load placed on the global environment.

Further, according to this embodiment, the alloy contained in each of the L0 recording layer 43 and the L1 recording layer 53 of the optical recording medium 30 as a primary component has a composition $[x_1, y_1, z_1]$ in the ternary composition diagram shown in Figure 1, in which x_1 , y_1 and z_1 represent atomic ratios (atomic %) of Fe, Al and Si contained in the alloy, such that each of x_1 , y_1 and z_1 falls within a region 100 of a pentagon defined by straight lines connecting a point A [57, 43, 0], a point B [0, 55, 45], a point C [15, 0, 85], a point D [89, 11, 0] and a point E [0, 16, 84] in the ternary composition diagram. It is therefore possible to reproduce a signal having a high C/N ratio and low jitter, effectively suppress data cross-talk and improve the recording sensitivity of the optical recording

medium 30.

WORKING EXAMPLES AND COMPARATIVE EXAMPLES

Hereinafter, a working example and a comparative example will be
5 set out in order to further clarify the advantages of the present invention.

Working Example 1

An optical recording medium sample #1-1 was fabricated in the
following manner.

10 A disk-like polycarbonate substrate having a thickness of 1.1 mm
and a diameter of 120 mm and formed with grooves and lands on the
surface thereof was first fabricated by an injection molding process so
that the track pitch (groove pitch) was equal to 0.32 μm .

Then, the polycarbonate substrate was set on a sputtering
15 apparatus and a reflective layer consisting of an alloy containing Ag, Pd
and Cu and having a thickness of 100 nm, a second dielectric layer
containing a mixture of ZnS and SiO_2 and having a thickness of 35 nm, a
recording layer containing as a primary component an alloy containing Fe
and Al and having a thickness of 10 nm and a first dielectric film
20 containing the mixture of ZnS and SiO_2 and having a thickness of 20 nm
were sequentially formed on the surface of the polycarbonate substrate on
which the grooves and lands were formed, using the sputtering process.

The mole ratio of ZnS to SiO_2 in the mixture of ZnS and SiO_2
contained in the first dielectric layer and the second dielectric layer was
25 80:20.

The recording layer contained an alloy containing 80 atomic % of
Fe and 20 atomic % of Al as a primary component.

Further, the polycarbonate substrate formed with the reflective

layer, the second dielectric layer, the recording layer and the first dielectric layer on the surface thereof was set on a spin coating apparatus and the first dielectric layer was coated using the spin coating method with a resin solution prepared by dissolving acrylic ultraviolet ray curable resin in a solvent to form a coating layer and the coating layer was
5 irradiated with ultraviolet rays, thereby curing the acrylic ultraviolet ray curable resin to form a light transmission layer having a thickness of 100 μm .

Thus, the optical recording medium sample #1-1 was fabricated.

10 Further, an optical recording medium sample #1-2 was fabricated in the same way as the optical recording medium sample #1-1 except that the second dielectric layer was formed to have a thickness of 15 nm, the first dielectric layer was formed to have a thickness of 50 nm and the recording layer was formed to contain an alloy containing 16 atomic % of
15 Al and 84 atomic % of Si as a primary component.

Moreover, an optical recording medium sample #1-3 was fabricated in the same way as the optical recording medium sample #1-1 except that the second dielectric layer was formed to have a thickness of 35 nm, the first dielectric layer was formed to have a thickness of 20 nm and the
20 recording layer was formed to contain an alloy containing 32 atomic % of Fe, 42 atomic % of Al and 26 atomic % of Si as a primary component.

Further, an optical recording medium sample #1-4 was fabricated in the same way as the optical recording medium sample #1-1 except that the second dielectric layer was formed to have a thickness of 15 nm, the
25 first dielectric layer was formed to have a thickness of 40 nm and the recording layer was formed to contain an alloy containing 55 atomic % of Al and 45 atomic % of Si as a primary component.

Furthermore, an optical recording medium sample #1-5 was

fabricated in the same way as the optical recording medium sample #1-1 except that the second dielectric layer was formed to have a thickness of 35 nm, the first dielectric layer was formed to have a thickness of 20 nm and the recording layer was formed to contain an alloy containing 57
5 atomic % of Fe and 43 atomic % of Al as a primary component.

Moreover, an optical recording medium sample #1-6 was fabricated in the same way as the optical recording medium sample #1-1 except that the second dielectric layer was formed to have a thickness of 20 nm, the first dielectric layer was formed to have a thickness of 20 nm and the
10 recording layer was formed to contain an alloy containing 15 atomic % of Fe and 85 atomic % of Si as a primary component.

Further, an optical recording medium sample #1-7 was fabricated in the same way as the optical recording medium sample #1-1 except that the second dielectric layer was formed to have a thickness of 35 nm, the
15 first dielectric layer was formed to have a thickness of 20 nm and the recording layer was formed to contain an alloy containing 12 atomic % of Fe, 15 atomic % of Al and 73 atomic % of Si as a primary component.

Furthermore, an optical recording medium sample #1-8 was fabricated in the same way as the optical recording medium sample #1-1
20 except that the second dielectric layer was formed to have a thickness of 35 nm, the first dielectric layer was formed to have a thickness of 20 nm and the recording layer was formed to contain an alloy containing 10 atomic % of Fe, 29 atomic % of Al and 61 atomic % of Si as a primary component.

25 Moreover, an optical recording medium sample #1-9 was fabricated in the same way as the optical recording medium sample #1-1 except that the second dielectric layer was formed to have a thickness of 15 nm, the first dielectric layer was formed to have a thickness of 40 nm and the

recording layer was formed to contain an alloy containing 27 atomic % of Al and 73 atomic % of Si as a primary component.

Further, an optical recording medium sample #1-10 was fabricated in the same way as the optical recording medium sample #1-1 except that
5 the second dielectric layer was formed to have a thickness of 35 nm, the first dielectric layer was formed to have a thickness of 20 nm and the recording layer was formed to contain an alloy containing 50 atomic % of Fe, 19 atomic % of Al and 31 atomic % of Si as a primary component.

Furthermore, an optical recording medium sample #1-11 was
10 fabricated in the same way as the optical recording medium sample #1-1 except that the second dielectric layer was formed to have a thickness of 35 nm, the first dielectric layer was formed to have a thickness of 30 nm and the recording layer was formed to contain an alloy containing 89 atomic % of Fe and 11 atomic % of Al as a primary component.

Moreover, an optical recording medium sample #1-12 was
15 fabricated in the same way as the optical recording medium sample #1-1 except that the second dielectric layer was formed to have a thickness of 35 nm, the first dielectric layer was formed to have a thickness of 20 nm and the recording layer was formed to contain an alloy containing 26
20 atomic % of Fe, 27 atomic % of Al and 47 atomic % of Si as a primary component.

Further, an optical recording medium sample #1-13 was fabricated in the same way as the optical recording medium sample #1-1 except that
the second dielectric layer was formed to have a thickness of 35 nm, the
25 first dielectric layer was formed to have a thickness of 20 nm and the recording layer was formed to contain an alloy containing 50 atomic % of Fe, 38 atomic % of Al and 12 atomic % of Si as a primary component.

Furthermore, an optical recording medium sample #1-14 was

fabricated in the same way as the optical recording medium sample #1-1 except that the second dielectric layer was formed to have a thickness of 35 nm, the first dielectric layer was formed to have a thickness of 20 nm and the recording layer was formed to contain an alloy containing 10
5 atomic % of Fe, 53 atomic % of Al and 37 atomic % of Si as a primary component.

The alloy contained as a primary component in the recording layer of each of the optical recording medium samples #1-1 to #1-14 had a composition $[x_1, y_1, z_1]$ in the ternary composition diagram of the alloy, in
10 which x_1 , y_1 and z_1 represented atomic ratios (atomic %) of Fe, Al and Si contained in the alloy, such that each of x_1 , y_1 and z_1 fell within a region of a pentagon defined by straight lines connecting a point A [57, 43, 0], a point B [0, 55, 45], a point C [15, 0, 85], a point D [89, 11, 0] and a point E [0, 16, 84] in the ternary composition diagram shown in Figure 1.

15

Comparative Example 1

An optical recording medium comparative sample #2-1 was fabricated in the same way as the optical recording medium sample #1-1 except that the second dielectric layer was formed to have a thickness of
20 35 nm, the first dielectric layer was formed to have a thickness of 20 nm and the recording layer was formed to contain an alloy containing 91 atomic % of Al and 9 atomic % of Si as a primary component.

Further, an optical recording medium comparative sample #2-2 was fabricated in the same way as the optical recording medium sample
25 #1-1 except that the second dielectric layer was formed to have a thickness of 35 nm, the first dielectric layer was formed to have a thickness of 20 nm and the recording layer was formed to contain an alloy containing 36 atomic % of Fe and 64 atomic % of Si as a primary

component.

Furthermore, an optical recording medium comparative sample #2-3 was fabricated in the same way as the optical recording medium sample #1-1 except that the second dielectric layer was formed to have a thickness of 15 nm, the first dielectric layer was formed to have a thickness of 40 nm and the recording layer was formed to contain an alloy containing 79 atomic % of Al and 21 atomic % of Si as a primary component.

Moreover, an optical recording medium comparative sample #2-4 was fabricated in the same way as the optical recording medium sample #1-1 except that the second dielectric layer was formed to have a thickness of 35 nm, the first dielectric layer was formed to have a thickness of 20 nm and the recording layer was formed to contain an alloy containing 60 atomic % of Fe and 40 atomic % of Si as a primary component.

Further, an optical recording medium comparative sample #2-5 was fabricated in the same way as the optical recording medium sample #1-1 except that the second dielectric layer was formed to have a thickness of 36 nm, the first dielectric layer was formed to have a thickness of 20 nm and the recording layer was formed to contain an alloy containing 33 atomic % of Fe and 67 atomic % of Al as a primary component.

Furthermore, an optical recording medium comparative sample #2-6 was fabricated in the same way as the optical recording medium sample #1-1 except that the second dielectric layer was formed to have a thickness of 35 nm, the first dielectric layer was formed to have a thickness of 20 nm and the recording layer was formed to contain an alloy containing 82 atomic % of Fe and 18 atomic % of Si as a primary

component.

The alloy contained as a primary component in the recording layer of each of the optical recording medium comparative samples #2-1 to #2-6 had a composition $[x_1, y_1, z_1]$ in the ternary composition diagram of the alloy, in which x_1 , y_1 and z_1 represented atomic ratios (atomic %) of Fe, Al and Si contained in the alloy, such that each of x_1 , y_1 and z_1 fell within a region 101 or a region 102 outside of the region of a pentagon defined by straight lines connecting the point A [57, 43, 0], the point B [0, 55, 45], the point C [15, 0, 85], the point D [89, 11, 0] and the point E [0, 16, 84] in the ternary composition diagram shown in Figure 1.

Each of the optical recording medium samples #1-1 to #1-14 and #2-1 to #2-6 was set in an optical recording medium evaluation apparatus "DDU1000 "(Product Name) manufactured by Pulstec Industrial Co., Ltd. and a laser beam having a wavelength of 405 nm whose power was modulated in accordance with the pulse pattern shown in Figure 9 was focused onto the recording layer using an objective lens whose numerical aperture was 0.85 via the light transmission layer while each of the samples was rotated at a linear velocity of 5.3 m/sec, thereby recording a random signal including a 2T signal to an 8T signal therein in the 1,7 RLL Modulation Code.

The recording power of the laser beam was set to 7.0 mW, while the bottom power of the laser beam was fixed at 0.1 mW.

Then, each of the optical recording medium samples #1-1 to #1-14 and #2-1 to #2-6 was set in the above mentioned optical recording medium evaluation apparatus and a laser beam having a wavelength of 405 nm was focused onto the recording layer of each sample using an objective lens whose numerical aperture was 0.85 via the light transmission layer while each sample was rotated at a linear velocity of 5.3 m/sec, thereby

reproducing a signal recorded in the recording layer and jitter of the reproduced was measured. The reproducing power of the laser beam was set to 0.3 mW.

Further, similarly to the above, a random signal was recorded in each of the optical recording medium samples #1-1 to #1-14 and #2-1 to #2-6 while increasing the recording power of the laser beam in increments of 0.2 mW up to 10.0 mW and a signal reproduced from each sample similarly to the above was measured.

The lowest jitter was determined from among the thus measured jitters and the recording power at which the jitter of the reproduced signal was lowest was determined as an optimum recording power of the laser beam.

Then, each of the optical recording medium samples #1-1 to #1-14 and #2-1 to #2-6 was set in the above mentioned optical recording medium evaluation apparatus and an 8T signal in the 1,7 RLL Modulation Code was recorded in the recording layer of each sample similarly to the above except that the recording power of the laser beam was set to the optimum recording power.

Further, each of the optical recording medium samples #1-1 to #1-14 and #2-1 to #2-6 was set in the above mentioned optical recording medium evaluation apparatus and similarly to the above, a signal recorded in the recording layer of each sample was reproduced, thereby measuring a C/N ratio of the reproduced signal.

The results of the measurement are shown in Table 1.

Table 1

Sample #	C/N (dB)
Sample # 1-1	51.6
Sample # 1-2	51.5
Sample # 1-3	49.5
Sample # 1-4	49.5
Sample # 1-5	49.2
Sample # 1-6	49.2
Sample # 1-7	49.1
Sample # 1-8	48.7
Sample # 1-9	48.5
Sample # 1-10	48.2
Sample # 1-11	46.9
Sample # 1-12	46.8
Sample # 1-13	46.1
Sample # 1-14	45.5
Comparative Sample # 2-1	43.5
Comparative Sample # 2-2	42.8
Comparative Sample # 2-3	41.3
Comparative Sample # 2-4	40.9
Comparative Sample # 2-5	39.0
Comparative Sample # 2-6	35.2

As shown in Table 1, it was found that the C/N ratio of the reproduced signal reproduced from each sample was equal to or higher than 35 dB and that each sample including the recording layer containing as a primary component an alloy containing at least two elements
5 selected from the group consisting of Fe, Al and Si could be practically used as an optical recording medium.

In particular, as shown in Table 1, it was found that the C/N ratio of the reproduced signal reproduced from each of the optical recording medium samples #1-1 to #1-14 was equal to or higher than 45 dB and
10 sufficiently high and that each of the optical recording medium samples #1-1 to #1-14 had excellent signal characteristic, since the correlation between the C/N ratio and jitter of a reproduced signal is relatively low in the case where the C/N ratio is equal to or higher than 45 dB, whereas jitter of a reproduced signal greatly increases as the C/N ratio thereof
15 decreases in the case where the C/N ratio is lower than 45 dB.

The present invention has thus been shown and described with reference to specific embodiments and working examples. However, it should be noted that the present invention is in no way limited to the details of the described arrangements but changes and modifications may
20 be made without departing from the scope of the appended claims.

For example, in the optical recording medium 10 shown in Figures 3 and 4, although the recording layer 14 is sandwiched by the second dielectric layer 23 and the first dielectric layer 15, only one of the second dielectric layer 23 and the first dielectric layer 15 may be formed to be
25 adjacent to the recording layer 14. Similarly, in the optical recording medium 30 shown in Figure 10, each of the L0 information recording layer 40 and the L1 information recording layer 50 may include a single dielectric layer.

Moreover, although the optical recording medium 10 shown in Figures 3 and 4 includes the reflective layer 12 on the support substrate 11, in the case where the difference in reflection coefficients between a region of the recording layer 14 where a record mark is formed and a blank region is great, the reflective layer 12 may be omitted.

Further, in the above described embodiments, although each of the reflective layer 12, the reflective layer 41 and the reflective layer 51 is constituted as a single layer, each of the reflective layer 12, the reflective layer 41 and the reflective layer 51 may have a multi-layered structure.

Furthermore, in the embodiment shown in Figure 10, the L1 information recording layer 50 includes a reflective layer 51, but since a laser beam L passes through the L1 information recording layer 50 when the laser beam L is projected onto the L0 information recording layer 40, the L1 information recording layer 50 may be provided with no reflective layer or an extremely thin reflective layer in order to increase the light transmittance of the L1 information recording layer 50.

Moreover, although the optical recording medium 10 includes the single recording layer 14 as an information recording layer in the embodiment shown in Figures 3 and 4 and the optical recording medium 30 includes the L0 information recording layer 40 and the L1 information recording layer 50 in the embodiment shown in Figure 10, an optical recording medium may include three or more information recording layer.

Further, the optical recording medium 10 includes the light transmission layer 16 and is constituted so that a laser beam L is projected onto the recording layer 14 via the light transmission layer 16 in the embodiment shown in Figures 3 and 4, and the optical recording medium 30 includes the light transmission layer 33 and is constituted so that a laser beam L is projected onto the L1 information recording layer

50 or the L0 information recording layer 40 via the light transmission layer 33 in the embodiment shown in Figure 10. However, the present invention is not limited to optical recording media having such configurations and the optical recording medium may include a substrate
5 formed of a light transmittable material and be constituted so that a laser beam L is projected onto the recording layer 14, or the L1 information recording layer 50 or the L0 information recording layer 40 via the substrate.

According to the present invention, it is possible to provide an
10 optical recording medium including a recording layer formed of materials which apply minimal load to the global environment.

Further, according to the present invention, it is possible to provide a method for manufacturing an optical recording medium including a recording layer formed of materials which apply minimal load
15 to the global environment.

Furthermore, according to the present invention, it is possible to provide a target used for a sputtering process, which can form a recording layer of an optical recording medium of materials that place minimal load on the global environment.